

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	:	Raaijmakers et al.	)	Group Art Unit Unknown
			)	
Appl. No.	:	Unknown	)	
			)	
Filed	:	Herewith	)	
			)	
For	:	METHOD OF DEPOSITING	)	
		SILICON WITH HIGH STEP	)	
		COVERAGE	)	
			)	
Examiner	:	Unknown	)	

**PRELIMINARY AMENDMENT**

Assistant Commissioner for Patents  
Washington, D.C. 20231

Dear Sir:

Prior to examination on the merits, please amend the above-captioned application as indicated below.

**IN THE SPECIFICATION**

On page 1, after the title, insert the following heading and paragraph:

--Reference to Related Applications

The present application is a divisional of U.S. Patent Application No. 09/264,167 filed March 5, 1999, which claims the priority benefit under 35 U.S.C. § 119(e) for provisional Application No. 60/077,082, filed March 6, 1998.--

**IN THE CLAIMS**

Please cancel Claims 1-32.

Appl. No. : Unknown  
Filed : Herewith

REMARKS

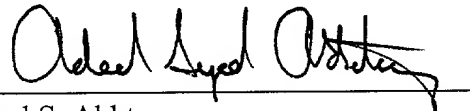
In view of the foregoing amendments, Applicants submit that the application is in condition for examination on the merits and respectfully requests the same.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: January 18, 2001

By: \_\_\_\_\_



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